



0500

Atty. Docket No.: 15675.P322

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

C. Chappert

Application No.: 09/600,546

Filed: 7/12/00

For: **MAGNETIC ETCHING PROCESS,  
ESPECIALLY FOR MAGNETIC OR  
MAGNETO-OPTIC RECORDING**

Art Group: 1756

#36125

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents  
Washington, D.C. 20231

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Dear Sir:

Pursuant to Rule 1.97, Applicant desires to make of record the references set forth on the attached Form PTO 1449 which were cited in a search report dated October 21, 1998 and March 19, 1999 of the corresponding PCT application. Enclosed is a copy of the search report which indicates the degree of relevance found by the foreign office where documents cited as category X are deemed relevant when taken alone; documents cited as category Y are deemed relevant when taken in combination with another reference; documents cited as category T are directed to the theory or principle underlying the invention; and documents cited as category A are deemed relevant as technological background defining the general state of the art. Copies of these references are submitted herewith.

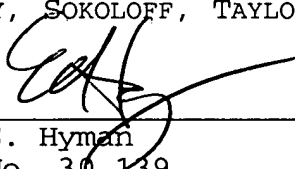
It is hereby stated that this Information Disclosure Statement is being filed within three months of the filing date of the subject application, therefore no petition or fee is required. However, in the event a petition is needed for consideration of this Information Disclosure Statement, Applicant hereby so petitions. Please charge any additional fee due to Deposit Account 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: \_\_\_\_\_

8/14/00

  
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**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on: September 14, 2000.

9/14/00  
Lynda Shapiro

9-14-00  
9/11/00  
Date